

Docket No. 1759.011**INTERVIEW SUMMARY**

A telephone interview between Examiner Johnson and applicants' undersigned attorney was held on January 29, 2003. (Applicants note here that the Examiner's effort and commitment in expediting the prosecution of the application is appreciated.) The teachings of U.S. Patent No. 6,228,480, to Kimura et al., were discussed, particularly with respect to binding of a photocatalyst to a support structure.